

FEATURED ALUM-A-LIFT SEMICONDUCTOR PROCESS TOOL ASSEMBLY LIFT

PROJECT 32304



MODEL A800CLR-78

FEATURING Interchangeable Gripper Pads, Manual Adjustable Width Clamp, Powered Rotation, Tilt Up/Deflection Compensation

HANDLING 300lb [136 kg] Process Tool Frames

DETAILS Built for a market leading semiconductor supplier, this lift is designed to aid in the assembly of deposition, plasma etch, photoresist strip, and wafer cleaning process tools. Specialized gripper pads can be interchanged to handle different configurations and the adjustable width clamp arms can be set to handle a wide range of tool frame sizes. The ergonomic powered rotation allows the frame to be oriented for improved installation access. The resulting system was able to replace various fixed frames and overhead systems.

